

WORKSHOP on Maskless Direct-Write Technologies for the Advanced Micro & Nano-Fabrication

Date: 12 Dec 2023

09:30 AM to 01:30 PM

Venue

**Hall-3, IC & SR, IIT
Madras, Chennai**

Click on the link for
Registration or scan the
QR code

<https://t.ly/8ySG9>



**Know more about Heidel-
berg Instruments Mikro-
technik**



Labindia Instruments Pvt. Ltd
201, Nand Chambers, L B S Marg,
Near Vandana Cinema,
Thane - 400 602.

Program Agenda

9:30 am to 10:00 am	Registration
10:00 AM – 10:30 AM	Introduction by CNNP
10:30 AM – 11:15 PM	Heidelberg Instruments – Company and Product Overview – focus on Maskless Aligner and Maskless Stepper by Dr. Sven Preuss Heidelberg Instruments
11:15 AM – 11:45 PM	Empowering microfabrication research with the DWL66+ and unveiling the potential of grayscale lithography. by Dominique Collé, Heidelberg Instruments
11:45 am to 12:00 pm Coffee/Tea Break	
12:00 PM – 12:30 PM	Laser lithography 2D and 3D corrections by Dmitri Titko, GenISys
12:30 PM – 13:00 PM	NanoFrazor Lithography for advanced 2D&3D nanodevices by Vasileios Theofylaktopoulos, Heidelberg Instruments
13:00 PM – 13:30 PM	The MPO 100: 3D Lithography and 3D Microprinting via Two-Photon Polymerization by Dr. Daniel-Alexander Braun, Heidelberg Instruments
Lunch and Networking	

Contact US

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